

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Norio KIMURA et al. :
Serial No. NEW : **Attn: APPLICATION BRANCH**
Filed October 28, 2003 : Attorney Docket No. 2003-1482

POLISHING METHOD AND APPARATUS
(Rule 1.53(b) Divisional
of Serial No. 09/545,504,
Filed April 7, 2000)

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

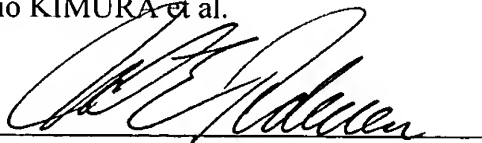
Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 11-101125, filed April 8, 1999, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 09/545,504, filed April 7, 2000.

Respectfully submitted,

Norio KIMURA et al.

By



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